

Confirmation no. 3423

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DE BOER	Examiner:	Lund, J.
Serial No.:	10/537,363	Group Art Unit:	1792
Filed:	June 2, 2005	Docket No.:	US020527US
Title:	SYSTEM AND METHOD FOR SUPPRESSION OF WAFER TEMPERATURE DRIFT IN COLD-WALL CVD SYSTEMS		

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Customer No.
65913

1. This is a request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.
2. Attached please find:
 - a. An Amendment with Request for Continued Examination, submitted herewith to advance the above-referenced patent application under a final rejection dated November 19, 2008.
3. Fees:
 - a. Please charge Deposit Account Number 50-0996 (NXPS.441PA) the below RCE filing fee, with authorization to charge/credit said deposit account any additional required claims fees/overages to complete this filing.
 1. **The RCE filing fee \$810.00.**

Please direct all correspondence to:

Corporate Patent Counsel
NXP Intellectual Property & Standards
1109 McKay Drive; Mail Stop S41-SJ
San Jose, CA 95131

By:


Name: Robert J. Crawford
Reg. No.: 32,122
(NXPS.441PA)

Customer No. 65913